



Homogeneous Cu₂O p-n junction photocathodes for solar water splitting

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ABSTRACT

Cu₂O is considered as one of the most promising p-type semiconductors for photocathodes in solar water splitting due to its abundance, nontoxicity and appropriate band gap of 2.0 eV with favorable energy band positions. It has been long desired to find a proper n type semiconductor for p-Cu₂O to form a p-n junction to generate a more positive onset potential. However, most previous research adopted heterogeneous p-n junctions due to the difficulty in obtaining n-type Cu₂O, and the utilization of p-n Cu₂O homojunction was limited to solid-state photovoltaic devices. This paper describes a facile electrodeposition process for n-type Cu₂O to construct the homogenous p-n junction, which is further protected by TiO₂ for water splitting, demonstrating the possibility of applying Cu₂O p-n homojunction in an aqueous condition for the first time. Compared with the heterogeneous Schottky junction counterpart, this p-n homojunction significantly increases the built-in potential for efficient charge separation, which leads to an anodic onset potential shift from 0.3 V to 0.7 V versus the reversible hydrogen electrode (RHE), reaching a photocurrent of 4.30 mA/cm² at 0 V vs. RHE under AM1.5G. The performance of this electrodeposited p-n Cu₂O photocathode without using the expensive Au back contact is comparable to the most efficient Cu₂O photocathodes reported previously.

1. Introduction

Cuprous oxide (Cu₂O) has been considered to be a promising candidate for high-efficient low cost p-type semiconductor in photoelectrochemical water splitting [1]. Although Cu₂O can generate a photovoltage up to 0.8 V in a non-aqueous system [2], the performance of this photocathode in aqueous electrolyte is far below expectation because of its instability that prevents the direct contact between Cu₂O and electrolyte to form a solid-liquid junction, as well as the difficulty in forming high-quality buried junctions, with only a few encouraging reports.

The pioneering work has shown that atomic layer deposition (ALD) grown aluminum doped zinc oxide (AZO) could form a buried junction with Cu₂O to generate photovoltage in aqueous electrolyte [1]. Although being effective, AZO forms a Schottky junction with p-Cu₂O, which means relatively close Fermi level positions and the existence of interface defects. The theoretical Fermi level offset between ZnO (4.2 eV versus vacuum level) and Cu₂O (4.9 eV versus vacuum level) is estimated to be 0.7 V [3], which largely limits the possible separation of the quasi-Fermi levels upon illumination for photovoltage generation. In addition, the actual band bending at the Cu₂O/AZO Schottky junction is far below 0.7 V due to the pinning of Fermi level caused by

interface defects [4]. Thus, many recent studies focus on finding proper n-type semiconductors to form p-n junctions with p-Cu₂O to generate larger photovoltage.

The n-type material of the p-n heterojunction should have a suitable conduction band alignment and high-quality interface with the p-Cu₂O layer. In practice, however, the choice of this n-type material is not so straightforward since the band alignment is rarely ideal and the existence of interface defects is inevitable [5]. Delaunay and co-workers introduced a thin Ga₂O₃ as a n-type layer that forms a p-n junction with Cu₂O to improve the performance of Cu₂O-based photocathodes [6]. This Cu₂O-Ga₂O₃ p-n junction reduces the conduction band discontinuity along the interface, thus achieving an extremely positive onset potential of 1.02 V and a high cathodic photocurrent of −2.95 mA/cm² at 0 V vs. RHE. Wang and co-workers prepared a thin ZnS n-type layer to form a high quality interface with Cu₂O to increase the photovoltage to 0.72 V [7]. ZnS has a reported conduction band position of 3.9 eV versus vacuum level which lies close to its Fermi level [8]. Therefore the Fermi level offset of Cu₂O/ZnS is expected to be 1.0 eV. These p-Cu₂O/n-type semiconductor junctions outperforms the p-Cu₂O/AZO Schottky junctions, confirming the importance of n-type oxide for p-Cu₂O to generate photovoltage and improve the solar energy conversion efficiency. However, it is very likely that defects still

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exist at the interface of heterogeneous Cu₂O/n-type semiconductor junctions [5]. The lattice mismatch between the crystal structures of different materials can increase charge recombination and hamper the photovoltage and photocurrent. Thus it can be inferred that although many previous research has demonstrated the success in forming heterogeneous p-n or Schottky junctions [1,6,7], homogeneous Cu₂O p-n junction is still highly desired.

The homogeneous Cu₂O p-n junction offers unique advantages compared to heterojunctions. (I) The electron affinity of p-Cu₂O and n-Cu₂O is approximately equal to each other, thus decreasing the conduction band discontinuity along the interface [9,10]. (II) It is possible to form a high quality interface at the junction with similar lattice spacing. However, there is scant research to construct Cu₂O homojunctions due to the lack of reliable methods to produce n-Cu₂O. Cu₂O is an intrinsic p-type semiconductor with a low electron affinity of 3.2 eV. It is often challenging to transfer materials with such a low electron affinity to n-type due to self-compensation by intrinsic defects [11]. Although the success in forming n-Cu₂O is limited, the electrodeposited n-Cu₂O thin films have been reported [12,13]. The strong Cu²⁺ absorption on the unstable surface states caused by the Cu vacancies of Cu₂O can form an inversion layer and transform the conductivity from p to n type [14]. So far, the Cu₂O p-n homojunction has been limited to solar cells, which is thought to be a way to reach the theoretical efficiency of 12% [5]. However, the n-Cu₂O contains a higher degree of lattice disorder with oxygen deficiency [14], which could be easily compensated by absorption of oxygen or water molecules [15]. Thus n-Cu₂O is extremely unstable. The stability of n-Cu₂O is expected to be worse than p-type Cu₂O, while the instability of the latter one in aqueous solutions is already a big problem, which originates from its redox potentials lying within its bandgap [16]. Although ALD-grown TiO₂ protective layers have been proven effective for p-Cu₂O [1,17,18], applying n-Cu₂O in aqueous electrolyte as the photocathode remains a great challenge.

In this work, we report a homogeneous Cu₂O p-n junction for solar water splitting in an aqueous environment for the first time, where the n-Cu₂O layer was fabricated by a facile electrodeposition method. By comparing the carrier lifetimes and photoelectrochemical performance between the homojunction and p-Cu₂O/AZO Schottky junction, we demonstrate the effectiveness of forming homojunction to further exploit the potential of Cu₂O as a photocathode.

2. Experimental section

2.1. Sample preparation

The Cu foil (2 cm × 2 cm) was gently polished by sandpaper to remove the native oxide on the surface and rinsed by deionized water. Then the Cu foil was immersed in the electrochemical polishing solution (H₃PO₄: PEG-400 = 3:1, in volume ratio) with another piece of Cu foil as counter electrode. The operating voltage was 1.5 V versus counter electrode and the treatment maintained for 30 min.

The p-type Cu₂O thin films were deposited by electrodeposition from a basic solution of lactate-stabilized cupric sulfate [19]. In brief, the plating bath was 0.4 M cupric sulfate anhydrous and 3 M lactic acid in aqueous solution. Prior to deposition, the bath pH value was adjusted to 11 through addition of sodium hydroxide and the temperature of the bath was maintained at 60 °C. The electrodeposition was conducted potentiostatically in a typical three-electrode system. The as prepared Cu foil was used as working electrode while a Pt foil and an Ag/AgCl (satd. KCl) were used as counter electrode and reference electrode, respectively. The electrodeposition potential was always kept at -0.4 V vs. Ag/AgCl for 5 min. Finally, the Cu₂O/Cu electrode was rinsed by deionized water.

The n-type Cu₂O was electrodeposited on top of the previously deposited p-type Cu₂O film [5]. The deposition bath was 0.02 M cupric acetate monohydrate and 0.08 M acetic acid in aqueous solutions. Prior

to deposition, the bath pH value was adjusted to 4.9 using sodium hydroxide and the temperature of the bath was maintained at 70 °C. The electrodeposition potential was always kept at +0.02 V vs. Ag/AgCl (satd. KCl) for 5 min. Afterwards, the p-n Cu₂O electrode was rinsed by deionized water and dried by flowing N₂.

For solid-state measurements, a 300 nm-thick Al film was deposited by e-beam evaporation on top of the Cu₂O film as the front contact, with the Cu substrate acting as the back contact. Two Cu wires were attached to the Al film and Cu, respectively, for electrical connection with the potentiostat.

For samples used for photoelectrochemical measurements, oxide overayers were deposited on p-n Cu₂O electrode by a home-made ALD system. Before ALD, the electrode was dipped in the 30% hydrogen peroxide for two times to remove the residual organic contaminants during the electrodeposition and saturate the Cu₂O surface with hydroxyl groups for ALD. The ALD precursors for Zn, Al and O of AZO were diethylzinc (DEZ), trimethylaluminum (TMA) and water, which were maintained at room temperature. Each precursor was dosed for 0.1 s, followed by a 15 s nitrogen purge. AZO layer was deposited by five supercycles consisting of 1 cycle of TMA and H₂O after 40 cycles of DEZ and H₂O, at 120 °C. The TiO₂ protective layer was deposited with titanium tetraisopropoxide (TTIP) and H₂O maintained at 50 °C and room temperature, respectively. Each precursor was dosed for 0.1 s, followed by a 10 s nitrogen purge. The process consisted of 1500 cycles.

Epoxy resin was applied before platinization to cover any exposed Cu electrode. In order to enhance the kinetics for water reduction reaction, Pt nanoparticles were deposited by galvanostatic photodeposition with a current density of -8.5 μA/cm² for 15 min under simulated one sun illumination using 1 mM aqueous solution of H₂PtCl₆.

2.2. Characterization

The morphology and microstructure of the films were characterized using a field-emission scanning electron microscopy (FESEM) (Hitachi S-4800, 5 kV) with energy-dispersive X-ray spectrum (EDX). The crystal structure was evaluated with X-ray diffractometer (D/MAX-2500), using Cu Kα radiation ($\lambda = 1.5416 \text{ \AA}$) at 40 kV and 140 mA. XRD spectra were acquired over a 2θ range of 20–80° at a scanning speed of 8° per minute. Time-resolved PL spectroscopy was performed on Fluorolog-3 of HORIBA Jobin Yvon. Solution concentration was detected by ICP-MS (7700x, Agilent).

2.3. Photoelectrochemical measurements

The photoelectrochemical performance of the photocathodes were evaluated in a three-electrode configuration, with the photocathodes as the working electrode, a platinum foil (2 cm × 2 cm) as the counter electrode and Ag/AgCl/sat. KCl as the reference electrode. The linear sweep voltammetry (J-V plots) and chronoamperometry (stability plots) were carried in an electrolyte solution of 0.5 M Na₂SO₄ and 0.1 M KH₂PO₄ at pH 4.15, under simulated AM 1.5G illumination (100 mW/cm²) using an Ivium Potentiostat/Galvanostat. The scan rate for the linear sweep voltammetry was 10 mV/s and the stability was tested at a fixed electrode potential of 0 V versus RHE. And the H₂ product was collected and analyzed by an on-line gas chromatograph (GC 2060, Ramiin) with a thermal conductivity detector (TCD) using Ar as the carrier gas. Prior to the test, the air tightness of the system was examined. The pressure of the system maintained at the range of 0.1 kPa–0.4 kPa (absolute pressure) in five hours, indicating the good air tightness of our system. Prior to the test, the electrolyte was purged with nitrogen gas to remove oxygen and thus eliminate erroneous signals arising from oxygen reduction. During the test, the electrolyte was continuously stirred during each measurement to detach the hydrogen from the surface of the TiO₂ protective layer. Mott-Schottky plots were obtained in a 0.2 M K₂SO₄ solution (pH 5.6) at 10 kHz. The charge carrier densities (N_A, cm⁻³) of Cu₂O photocathodes can be obtained from Mott-Schottky

plots and the equation of $1/C^2 = 2/(e\epsilon_r\epsilon_0N_A) \times (E-E_{fb}-kT/e)$, where C is the capacitance of the space charge region, $e = 1.60 \times 10^{-19}$ C, $\epsilon_r = 7.5$ is the relative permittivity of Cu₂O, $\epsilon_0 = 8.85 \times 10^{-14}$ F/cm is the permittivity of vacuum, E is the electrode applied potential, E_{fb} is the flat band potential, k is the Boltzmann constant, and T is the absolute temperature. The solar energy conversion efficiencies (η) were calculated according to the following equation $\eta = (V_{app} \times J_{ph})/P \times 100\%$, where V_{app} is the applied potential (vs. RHE), J_{ph} is the photocurrent (mA/cm²) under AM 1.5G irradiation and P is the irradiance of the AM 1.5G (100 mW/cm²). The incident photon-to-current conversion efficiencies (IPCE) were measured under monochromatic illumination at 0 V versus RHE using the equation $IPCE\% = [J_{ph}(\text{mA}/\text{cm}^2) \times 1240]/[P(\text{mW}/\text{cm}^2) \times \lambda(\text{nm})] \times 100$. The Faradaic efficiency (FE) for the hydrogen product was calculated according to the following equation $FE(\%) = \text{mol products} \times \text{number of electrons needed for conversion}/\text{moles of electrons passed} \times 100\%$.

3. Results and discussion

The p-Cu₂O thin films were deposited on Cu foils by electrodeposition from a basic solution of lactate-stabilized cupric sulfate, without using Au layer as the back contact. Following this step, an n-Cu₂O thin film was deposited on top of the as-prepared p-type Cu₂O layer to form a homojunction in the weakly acidic solution of cupric acetate. The bath pH was adjusted to 4.9 and the temperature was maintained at 70 °C. The electrodeposition potential was always kept at

+0.02 V vs. Ag/AgCl (satd. KCl). The p-type conductivity in Cu₂O is due to the copper vacancies. The acid solution can suppress copper vacancies and populate oxygen vacancies in Cu₂O, thus forming n-type films [20]. The p-n Cu₂O homojunction has larger built-in potential and less interface defects than the p-Cu₂O/AZO Schottky junction, which may greatly improve the water splitting performance. In addition, the p-n homojunction photocathode is protected by ALD-grown TiO₂ layer with AZO bonding layer, and activated with electrodeposited Pt for hydrogen evolution. So far, the utilization of consecutively electrodeposited p-n Cu₂O homojunction is limited to solid-state photovoltaic devices, due to the fact that n-type Cu₂O is extremely unstable in aqueous electrolytes. Owing to the dense TiO₂ protective layer enabled by ALD, this p-n homojunction eventually presents its potential in photoelectrochemical water splitting in this study.

3.1. Homogeneous p-n Cu₂O junction photocathodes

The morphology and perspective illustrations of different Cu₂O samples are shown in Fig. 1. The p-Cu₂O film show a cubic morphology (Fig. 1a). Upon the second electrodeposition for n-type layer, most of the p-Cu₂O surface could be covered by n-Cu₂O (Fig. 1b). After ALD of AZO and TiO₂, the morphology of Cu₂O photocathodes remained unchanged (Fig. 1c and d). The cross-sectional scanning electron microscopy (SEM) images of the Cu₂O homojunction show that the p-Cu₂O layer is about 1000 ± 70 nm thick, and the n-Cu₂O layer is about 500 ± 50 nm thick (Fig. S1). The ALD of AZO and TiO₂ was carried out

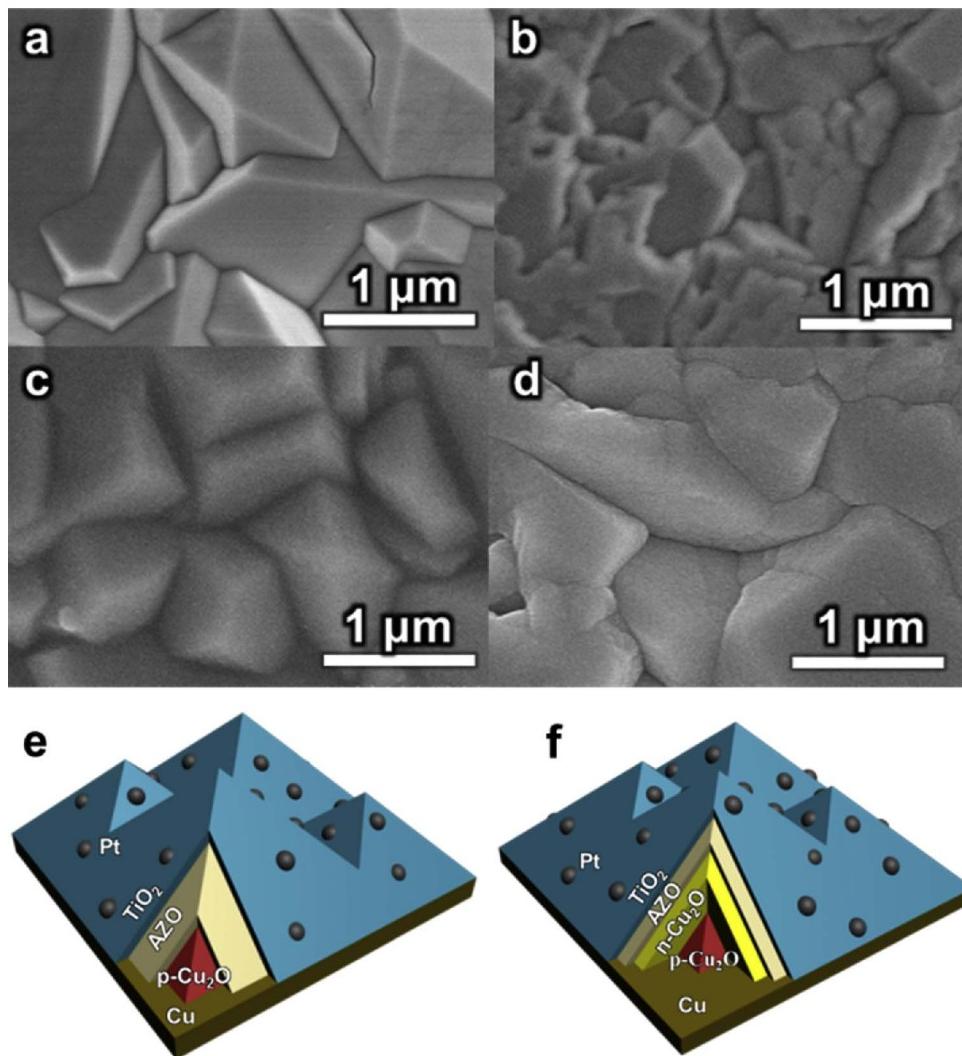
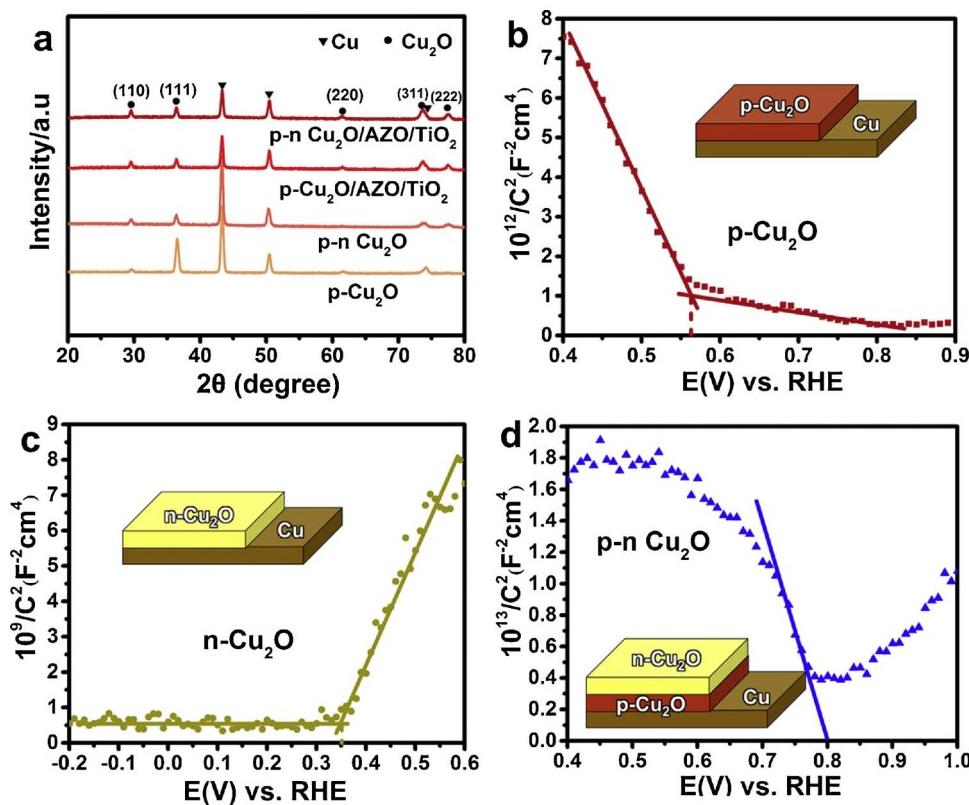


Fig. 1. Top view SEM images of (a) p-Cu₂O, (b) p-n Cu₂O, (c) p-Cu₂O/AZO/TiO₂, (d) p-n Cu₂O/AZO/TiO₂; Three-dimensional perspective views of (e) p-Cu₂O/AZO/TiO₂/Pt, (f) p-n Cu₂O/AZO/TiO₂/Pt.



at 120 °C and 150 °C, respectively. The ellipsometric thickness of AZO and TiO₂ are both 30 nm measured from Si monitor substrates.

To further evaluate the phase of the photocathodes, grazing incidence X-ray diffraction (GIXRD) measurements were performed (Fig. 2a). XRD peaks of Cu₂O on Cu electrodes could be obtained, exhibiting a predominant (111) orientation. The absence of AZO and TiO₂ signals is due to their thin thickness and low crystallinity. Mott-Schottky plots were obtained to investigate the conductive type of as-prepared Cu₂O films without AZO and TiO₂ layers. For p-type Cu₂O, the negative slope of the plot can be obtained (Fig. 2b), while the positive slope indicates the n type conductivity (Fig. 2c) [21]. The “V-shaped” behavior of the Mott-Schottky plot was observed for the p-n Cu₂O homojunction film (Fig. 2d), which could be interpreted as two capacitors in series, one corresponding to the p-Cu₂O/n-Cu₂O interface and the other to the n-Cu₂O/electrolyte interface [22]. The charge carrier concentration of Cu₂O electrode was calculated from the Mott-Schottky measurement (Table S1). To further confirm the n-type conductivity of Cu₂O, we fabricated Cu/Cu₂O/Al metal-insulator-metal (MIM) layer stacks for solid-state current-voltage (J-V) measurements. When the insulating layer is Cu₂O p-n junction, the MIM capacitor displays

rectifying characteristics, while the MIM capacitor with p-Cu₂O as the insulating layer exhibits ohmic characteristics (Fig. 3a), which verifies the n-type conductivity of the Cu₂O top layer. Meanwhile, the photoelectrochemical J-V curve of n-Cu₂O (without underlying p-Cu₂O) in direct contact with the electrolyte presents an anodic photocurrent, indicating the n-type conductivity of this layer (Fig. 3b).

The built-in potential (V_{bi}) of homogeneous Cu₂O p-n junction can be calculated according to the Mott-Schottky plot [23]. A linear fit of the region corresponding to the Cu₂O p-n junction (Fig. 2d, blue solid line) indicates that the V_{bi} is 0.8 V. The theoretical V_{bi} of the Cu₂O/ZnO heterojunction is 0.7 V according to the Fermi level offset between ZnO and Cu₂O [3]. However, the actual V_{bi} of Cu₂O/AZO Schottky junction is far below 0.7 V due to the interface defects which are known to influence the band bending [24,25]. Klein and co-workers have obtained a V_{bi} of 0.3 V for Cu₂O/AZO via X-ray photoelectron spectroscopy measurements [4]. The Cu₂O p-n junction presents a larger V_{bi} than Cu₂O/AZO Schottky junction due to the decrease of interfacial defects that largely release Fermi level pinning. Additionally, the V_{bi} remained the same when Mott-Schottky plots were obtained with different frequencies, assuring the result that Cu₂O p-n homojunction always

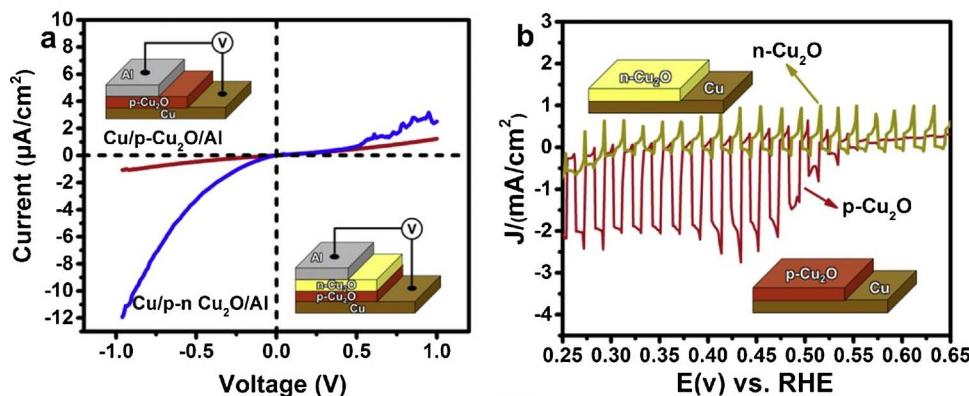
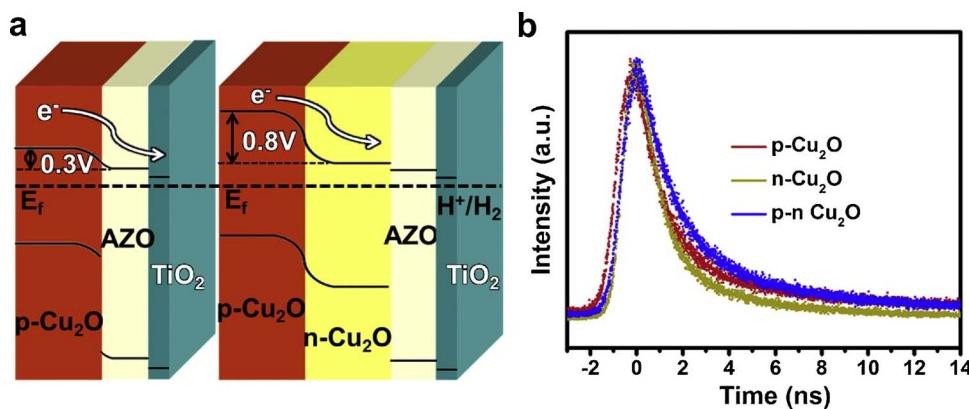


Fig. 3. (a) Solid-state J-V characteristics of the MIM capacitors. (b) The linear sweep voltammetry scans of the bare p-Cu₂O electrode and bare n-Cu₂O electrode. This J-V test was performed within 40 s, so the stability of the electrode was not a concern, as evidenced by the dark current restored to zero under chopped illumination. The anodic photocurrent of n-Cu₂O is much weaker than that of p-Cu₂O because of its low charge mobility.



exhibits a larger built-in potential than the Cu₂O/AZO heterojunction. Thus, the homogeneous Cu₂O p-n junction would form a larger splitting of the quasi-Fermi levels under illumination, which is expected to generate a larger photovoltage than the p-Cu₂O/AZO Schottky junction (Fig. 4a) [26,27].

In order to investigate the charge separation of the photocathodes, time-resolved photoluminescence (PL) spectroscopy was employed to monitor the fluorescence decay (Fig. 4b). The electrons and holes with long lifetimes would show slow PL decay, indicating efficient charge separation [28]. The experimental time-resolved PL intensity decay I(t) is analysed by using the following multi-exponential model [29]:

$$I(t) = b + \sum_{i=1}^n \alpha_i \exp(-t/\tau_i)$$

where τ_i (excited-state luminescence decay times) and α_i (pre-exponential factors) are parameters to be fitted, and b is a baseline correction parameter. The average decay time, $\langle \tau \rangle$, could be calculated from

$$\langle \tau \rangle = \frac{\sum_{i=1}^n \alpha_i \tau_i^2}{\sum_{i=1}^n \alpha_i \tau_i}$$

The fractional contribution f_i of each decay component was estimated by

$$f_i = \frac{\alpha_i \tau_i}{\sum_{j=1}^n \alpha_j \tau_j}$$

The Cu₂O samples were excited at 280 nm, and the PL was monitored at 535 nm. The p-n Cu₂O shows slower PL decay compared with p-Cu₂O and n-Cu₂O (Table 1 and Supplementary Table S2), confirming the enhanced charge separation, which could be attributed to the p-n Cu₂O homojunction that establishes an improved internal electric field [30]. Thus, the p-n homojunction photoelectrode is expected to present a higher activity than the Schottky heterojunction counterpart due to the enhanced interfacial charge separation, which is originated from the improved internal electric field.

3.2. Photoelectrochemical hydrogen evolution properties

Upon forming homogeneous p-Cu₂O/n-Cu₂O junction, the TiO₂-protected photocathodes exhibited noticeably improved photoelectrochemical performance (Fig. 5a). A positive onset potential of 0.7 V vs. RHE (defined as the potential where photocathodic current reaches 0.1 mA/cm² under AM 1.5G illumination) could be reached, with a 0.4 V positive shift compared to the p-Cu₂O/AZO Schottky junction. Meanwhile, a photocurrent of 4.30 mA/cm² at 0 V vs. RHE can be reached, 4.9 times higher than the p-Cu₂O/AZO sample (Table 2). The J-V curves present sharp spikes in each chopping cycle, owing to the contribution of capacitive currents [31], which was caused by the existence of depletion layer in the p-Cu₂O/n-Cu₂O interface, resulting in

Fig. 4. (a) Schematic band diagram of a TiO₂-protected p-n Cu₂O homojunction and p-Cu₂O/AZO Schottky junction, at equilibrium in the dark; (b) Time-resolved PL spectra of Cu₂O.

Table 1
Fitting of the time-resolved PL spectra of the samples.

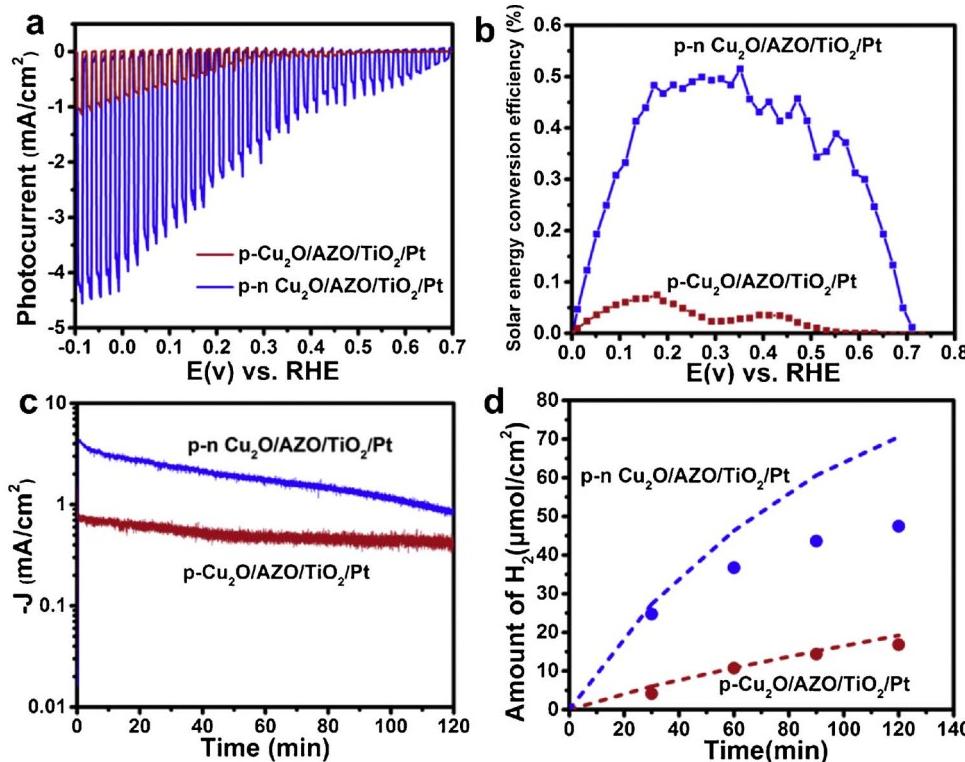
Samples	p-Cu ₂ O	n-Cu ₂ O	p-n Cu ₂ O
Decay life times (ns)	4.37	3.09	5.14

additional capacitance in the electrode [22]. It should be noted that our Cu₂O/AZO photocathode exhibits inferior performance compared to some recent high performance Cu₂O/AZO Schottky junction electrodes prepared by electrodeposition [1,32], most likely because the expensive Au layer is not used as ohmic back contact in this study. However, the performance of our Cu₂O p-n homojunction photocathode without Au layer is comparable to the most efficient Cu₂O/AZO photocathodes reported previously (Table S3). The Cu₂O photocathode prepared by thermal oxidation[6,7] exhibits superb performance due to high carrier mobility [16], but this method is rather complicated and requires the removal of CuO layer on the surface. Thus, we adopt a simple electrodeposition method to fabricate Cu₂O electrodes without using the expensive Au layer, which will sacrifice the activity. But our Cu₂O in p-n homojunction and Cu₂O/AZO Schottky junction was fabricated with the same method, which provides a reliable comparison to demonstrate the effectiveness of forming homojunction. Upon the formation of homogeneous p-n junction, our Cu₂O photocathode prepared by this facile electrodeposition process presents comparable performance to those prepared by thermal oxidation (Table S3).

A maximum solar energy conversion efficiency of 0.5% is achieved at 0.35 V vs. RHE for the TiO₂-protected homogeneous Cu₂O p-n junction electrode (Fig. 5b), which is seven times as high as the maximum solar energy conversion efficiency of p-Cu₂O/AZO Schottky heterojunction electrode. The p-n Cu₂O homojunction electrode presents a much higher the incident photon-to-current conversion efficiency (IPCE) than the p-Cu₂O/AZO electrode (Fig. S2), suggesting the improved charge collection due to the larger built-in potential at the p-Cu₂O/n-Cu₂O interface. By integrating the IPCE over the AM 1.5G spectrum, photocurrent density values of 0.89 and 4.65 mA/cm² could

Table 2
Performance for different Cu₂O photocathodes.

Samples	Onset potential (V vs. RHE)	Photocurrent at 0 V vs.RHE (mA/cm ²)	Solar energy conversion efficiency (%)
p-Cu ₂ O/AZO / TiO ₂ /Pt	0.3	0.87	0.07
p-Cu ₂ O/n-Cu ₂ O / AZO / TiO ₂ /Pt	0.7	4.30	0.50



be obtained for the p-Cu₂O/AZO/TiO₂/Pt and p-n Cu₂O/AZO/TiO₂/Pt photoelectrodes, respectively (Fig. S3), which are very close to 0.87 and 4.30 mA/cm² at 0 V vs. RHE obtained from the J-V measurement (Fig. 5a). This indicates that the measured J-V curves using our solar simulator are consistent with the IPCE data measured by our monochromator.

3.3. Photocathode stability and faradaic efficiency

The stability of the photocathodes in 0.5 M Na₂SO₄-0.1 M KH₂PO₄ electrolyte were evaluated under continuous AM 1.5G illumination at 0 V vs. RHE. The photocurrent of bare p-Cu₂O electrode and the bare p-n Cu₂O electrode without AZO/TiO₂ protective layer decreased significantly at the beginning of the stability test and almost lost their entire photoactivity within 30 min (Fig. S4), which is consistent with previous reports [33]. The Cu⁺ can be reduced to Cu⁰ by electrons or oxidized to Cu²⁺ by holes because the redox potentials for the reduction and oxidation of Cu⁺ lie within the bandgap of Cu₂O. The electrodes turned black due to the conversion of Cu₂O to Cu and CuO. To improve the stability of Cu₂O photocathodes in aqueous electrolytes, chemically stable oxide protective layers could be deposited by ALD. The TiO₂ growth follows a layer-by-layer mechanism on ZnO, while an island growth mode is expected on electrodeposited Cu₂O [1]. Thus, an AZO layer was introduced as a bonding layer to alter the TiO₂ growth mechanism to form a conformal protective layer on Cu₂O. The TiO₂ protective layer effectively prevents the Cu₂O layer from contacting the electrolyte solution while allowing photogenerated electrons to transfer through owing to its appropriate conduction band position. It is noted that the homogeneous Cu₂O p-n junction photocathode shows worse stability than the Cu₂O/AZO Schottky junction electrode (Fig. 5c). This may be because that n-Cu₂O is more vulnerable to corrosion and oxygen deficiency in n-Cu₂O is affected by water molecules through pinholes in TiO₂. The detachment of Pt cocatalyst is also a possible reason. After stability test, the electrolyte solution was detected by inductively coupled plasma mass spectrometry (ICP-MS) measurement, which revealed the existence of dissolved copper and other ions in the solution (Table

S4). Therefore, we explored thicker TiO₂ layers to extend our device lifetime by reducing the pinholes in the protective film. The stability of p-n Cu₂O photocathode could be largely enhanced when a 100 nm thick TiO₂ protective layer is utilized (Fig. S5).

The amounts of hydrogen produced from the photocathodes under AM 1.5G were measured at 0 V vs. RHE in 0.5 M Na₂SO₄-0.1 M KH₂PO₄ electrolyte (Fig. 5d). The Faradaic efficiencies (FE) of p-Cu₂O/AZO/TiO₂/Pt and p-n Cu₂O/AZO/TiO₂/Pt photoelectrodes are 84.78% and 67.24%, respectively. The low FE is due to the instability of the photocathodes, since the ALD-grown TiO₂ protective layer is not completely pinholes free, which requires further enhancement.

4. Conclusions

In conclusion, we demonstrate the successful construction of a homogeneous p-n Cu₂O junction photocathode for efficient water splitting by a facile electrodeposition without using Au layer as back contact. The p-n homojunction can enhance the band bending and eliminate lattice mismatch to generate a larger photovoltage and reduce the charge recombination. The longer PL decay time indicates the enhanced charge separation in the p-n Cu₂O homojunction. The onset potential for water reduction could be positively shifted from 0.3 to 0.7 V vs. RHE, and a cathode photocurrent of -4.30 mA/cm² at 0 V vs. RHE is obtained. A conformal TiO₂ protective layer can efficiently improve the stability of the p-n Cu₂O photocathode. This work reveals the importance of forming homogeneous p-n junctions over Schottky or p-n heterojunctions for solar water splitting. Many other photoactive semiconductors may adopt a similar strategy if a reliable method is developed to prepare these semiconductors with the opposite conductivity type, where new research opportunities are emerging.

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Appendix A. Supplementary data

Supplementary data associated with this article can be found, in the online version, at <https://doi.org/10.1016/j.apcatb.2017.12.022>.

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